



MAR 21 2005

03500.014241

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
NOBUHIRO ITO) : Examiner: B. Talbot
Application No.: 09/505,627) : Group Art Unit: 1762
Filed: February 16, 2000) :
For: MANUFACTURING METHOD OF)
ELECTRON BEAM APPARATUS :
AND SPACER, AND ELECTRON)
BEAM APPARATUS : March 18, 2005

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Since the U.S. Patent and Trademark Office waived the requirement under 37 C.F.R. § 1.98 (a)(2)(i) for submitting a copy of each cited U.S. patent and each U.S. patent application publication for all U.S. national patent applications and for all international applications that have entered the national stage under 35 U.S.C. § 371, no copies of such documents are enclosed.

Copies of the other listed document are enclosed.

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I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

March 18, 2005
(Date of Deposit)

Jason M. Okun
(Name of Attorney for Applicant)

Signature

March 18, 2005
Date of Signature

This Information Disclosure Statement is to make of record documents cited in an Official letter in the corresponding Japanese application.

The concise explanation of relevance of the non-English documents may be found, inter alia, in the English language abstracts attached thereto. In addition, the concise explanation of relevance for JP 2000-164129 may be found in U.S. Patent No. 6,517,399 B2, which is in the same patent family. The concise explanation of relevance for JP 8-508846 may be found in WO 94/18694, which is the same patent family. Lastly, the concise explanation of relevance for JP11-073897 may be found in U.S. Patent Nos. 6,153,973 and 6,353,280 B1, which are all in the same patent family.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

We also enclose a check for the required fee of \$180.00 to cover the Information Disclosure Statement under 37 C.F.R. § 1.97(c)(2).

Applicant's undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Jason M. Okun
Attorney for Applicant
Registration No. 48,512

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3800
Facsimile: (212) 218-2200

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICELIST OF REFERENCES CITED BY APPLICANT(S)
(Use several sheets if necessary.)

MAR 21 2005

APPLICANT

Nobuhiro Ito

FILING DATE

February 16, 2000

GROUP

1762

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	6,517,399 B2	02/11/03	Ito et al.	445	24	
	6,153,973	11/28/00	Shibata et al.	313	495	
	6,353,280 B1	03/05/02	Shibata et al.	313	292	

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
	EP	0 405 262 A1	01/02/91	Europe			
	WO	94/18694	08/18/94	International			
	JP	2000-164129	06/16/00	Japan			Abstract
	JP	11-73897	03/16/99	Japan			Abstract
	JP	8-508846	09/17/96	Japan			Abstract

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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